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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO	
09/807,394	04/12/2001	Henning Henningsen	GRP-0001	9224	
23413	7590 12/04/2003		EXAMINER:		
CANTOR COLBURN, LLP			LUK, EMMANUEL S		
	ROAD SOUTH LD, CT 06002		ART UNIT	PAPER NUMBER	
	-2, 02		1722		
			DATE MAILED: 12/04/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application N		Applicant(s)	
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Office Action Summary		09/807,394		HENNINGSEN, HENNING	
	omec Addon Gammary	Examiner		Art Unit	
		Emmanuel S.		1722	<u> </u>
Period 1	The MAILING DATE of this communication a for Reply	ppears on the co	ver sneet with the c	orrespondence a	daress
THE - Ext afte - If th - If N - Fai - Any	HORTENED STATUTORY PERIOD FOR REP MAILING DATE OF THIS COMMUNICATION ensions of time may be available under the provisions of 37 CFR or SIX (6) MONTHS from the mailing date of this communication. He period for reply specified above is less than thirty (30) days, a recommendation of the period for reply is specified above, the maximum statutory period une to reply within the set or extended period for reply will, by stature to received by the Office later than three months after the mail and patent term adjustment. See 37 CFR 1.704(b).	1. 1.136(a). In no event, heply within the statutory od will apply and will expute, cause the application.	nowever, may a reply be tim minimum of thirty (30) day bire SIX (6) MONTHS from on to become ABANDONE	nely filed s will be considered time the mailing date of this D (35 U.S.C. § 133).	
1)⊠	Responsive to communication(s) filed on 25	August 2003.			
2a)⊠	This action is FINAL . 2b) Thi	is action is non-f	inal.		
3)[_	Since this application is in condition for allow closed in accordance with the practice under				e merits is
Disposi	tion of Claims				
4)[Claim(s) 1-23 is/are pending in the application	on.			
	4a) Of the above claim(s) is/are withdr	rawn from consid	leration.		
5)[Claim(s) is/are allowed.				
6)⊠	Claim(s) <u>1-23</u> is/are rejected.				
7)[Claim(s) is/are objected to.				
8)[_	Claim(s) are subject to restriction and	or election requ	irement.		
Applica	tion Papers				
9)[The specification is objected to by the Examir	ner.			
10)	The drawing(s) filed on is/are: a) ac	ccepted or b)	objected to by the E	xaminer.	
	Applicant may not request that any objection to th	e drawing(s) be h	eld in abeyance. See	37 CFR 1.85(a).	
	Replacement drawing sheet(s) including the corre	ection is required it	the drawing(s) is obj	ected to. See 37 C	FR 1.121(d).
11)	The oath or declaration is objected to by the E	Examiner. Note t	he attached Office	Action or form P	TO-152.
Priority	under 35 U.S.C. §§ 119 and 120			•	
a	Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority document Certified copies of the priority document Copies of the certified copies of the priority document Copies of the certified copies of the priority document Copies of the certified copies of the priority document Copies of the certified copies of the priority Copies of the International Burestee the attached detailed Office action for a list	nts have been re nts have been re iority documents au (PCT Rule 17	eceived. eceived in Application have been received 7.2(a)).	on No d in this National	Stage
3	Acknowledgment is made of a claim for domes since a specific reference was included in the f 37 CFR 1.78. a) The translation of the foreign language p	irst sentence of	the specification or	in an Application	
14) 🗌	Acknowledgment is made of a claim for domes eference was included in the first sentence of	stic priority unde	35 U.S.C. §§ 120	and/or 121 since	
Attachme	nt(s)				
1) 🔀 Noti 2) 🔲 Noti	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449) Paper No(s)	5)	Interview Summary Notice of Informal Pa		

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 1, 2, 5, 7, 8, 10, 11 and 15-17 are rejected under 35 U.S.C. 103(a) as being unpatentable over by Fudim in view of Berlin (5790297).

Fudim teaches the claimed apparatus and method having a rapid prototyping machine for manufacturing 3-D objects(19), the apparatus having at least one light source (18) for illumination of a cross section of the light-sensitive material (11) by at least on spatial light modulator of individually controllable light modulators (20), wherein the at least one light source is optically coupled to a plurality of light guides (13) arranged with respect to the spatial light modulator arrangement in such a manner that each light guide illuminates a sub-area of the cross section (Col. 4, lines 42-48). The spatial modulator arrangement comprises transmissive light valves, optical fibers (14) constitute the optical light guides (13), the individual light valves are arranged in rows in a transverse direction of a surface at a given mutual distance, the rows being mutually displaced in the transverse direction (Fig. 4), the exposure head (18) comprising a bar having relative movement by the drives (16, 21) over the illumination surface, the optical means for spreading the light beams over the illumination surface.

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Fudim fails to teach at least two spatial light modulators of individually controllable light modulators.

Berlin teaches an array of light modulators (Col. 14, lines 10-15) that are individually controllable (Col. 14, lines 20-26) to compensate the failure of any one of the light modulators. The use of an array of light modulators allows for more power efficient operations than conventional scanning or projection devices (Col. 1, lines 18-23).

It would have been obvious to one of ordinary skill in the art to modify Fudim with an array of light modulators as taught by Berlin because it provides improved efficiency in operations.

3. Claims 3, 4, 6, 9, 13 and 14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Fudim in view of Berlin, as applied to claims 1, 2, 5, 7, 8, 10, 11 and 15-17, and further in view of Hull (4,929,402).

Fudim teaches the claimed apparatus as shown above. Fudim fails to teach micro lens, a short arc gap lamp, control circuitry and electromechanical light valves.

Hull teaches a rapid prototyping apparatus having a light source (26) using a 350 watt mercury short arc lamp in a housing focused on the end of a 1 mm diameter UV transmitting fiber optic bundle (Col. 7, lines 44-49). The bundle having an electronically controlled shutter blade between the lamp and the end of the bundle, that can turn the light through the bundle on and off, the optical output is fitted into a lens tube that has a quartz lens to focus the UV to a spot (Col. 7, lines 50-55). Hull also teaches that a UV

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laser is a better light source than a short arc lamp (Col. 5, lines 16-21) due to the intensity of the light source and the response of the UV curable liquid. Additionally, a computer (28) is utilized to control the basic functions of the stereolithographic functions.

The shutter blade is "electronically controlled" to turning the light in the bundle on and off, therefore the shutter blade is controlled by the computer. The shutter blade in conjunction with the fibers constitutes an electromechanical light valve. The computer comprises of control circuitry for controlling the elements of the stereolithographic apparatus. The lens tube acts as the micro lens for focusing the light source upon the material.

It would have been obvious to one of ordinary skill in the art to modify Fudim with a short arc lamp, control circuitry and micro lens as taught by Hull because it improved curing capabilities of the rapid prototyping apparatus with better response and intensity.

4. Claims 12, 18 and 19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Fudim in view of Berlin, as applied to claims 1, 2, 5, 7, 8, 10, 11 and 15-17, and further in view of Penn.

Fudim teaches the claimed apparatus as shown above.

Fudim fails to teach a modulator comprising of an LCD, PDLC, PLZT, FELCD or Kerr cell and multi-mode fibers.

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Penn teaches a rapid prototyping apparatus having an imager comprising of an LCD or LED, lasers, digital micro-mirrors, and other image projectors. Fudim does teach something similar to LED displays for use in the apparatus.

The multi-mode fibers are interpreted by the examiner as fibers being capable of transmitting the light at different frequencies and intensities. Fiber optics are capable of transmitting the light depending on the light source and therefore are capable of being multi-mode.

It would have been obvious to one of ordinary skill in the art to modify Fudim with LCD as taught by Penn for use in the apparatus since it is an equivalent device as shown by Penn.

5. Claim 20 is rejected under 35 U.S.C. 103(a) as being unpatentable over Fudim in view of Berlin and Hull as applied to claims 3, 4, 6, 9, 13 and 14, and further in view of Hagenau.

Fudim teaches the use of an array of miniature individually controlled mirrors that can be employed to modulate irradiation of individual fibers (Col. 4, lines 53-57).

Fudim fails to mention DMD.

Hagenau teaches that a DMD, is a digital micromirror device, and that a DMD array of micromirrors (46) is constructed on a semiconductor memory chip (Col. 7, lines 42-51). That the projection optics are selected to magnify the reflected image from the DMD (Col. 8, lines 1-3). The use of DMD's are widely known in the art and in fact, Fudim does teach DMD's in light of the teachings of Hagenau.

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It would have been obvious to one of ordinary skill in the art to recognize that the array of miniature individually controlled mirrors taught by Fudim are DMD's as shown by Hagenau.

Response to Arguments

6. Applicant's arguments with respect to claims 1-22 have been considered but are moot in view of the new ground(s) of rejection. The new rejections address the amended claims concerning at least two light modulators. This was the main focus of the arguments by the applicants in the previous remarks. Berlin teaches the use of an array of light modulators and one of ordinary skill in the art would be aware of this feature in the light projection arts.

Conclusion

7. Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any

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extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later

than SIX MONTHS from the date of this final action.

8. Any inquiry concerning this communication or earlier communications from the

examiner should be directed to Emmanuel S. Luk whose telephone number is (571)

272-1134. The examiner can normally be reached on Monday-Thursday 7 to 4 and

alternate Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Wanda L. Walker can be reached on (703) 308-0457. The fax phone

number for the organization where this application or proceeding is assigned is (703)

872-9306.

Any inquiry of a general nature or relating to the status of this application or

proceeding should be directed to the receptionist whose telephone number is (703) 308-

0651.

EL

W. L. WALKER
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 1700

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